

PATENT
P56432



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

CHUL-HAN BAE et al.

Serial No.: *to be assigned*

Examiner: *to be assigned*

Filed: 11 July 2001

Art Unit: *to be assigned*

For: TENSION MASK FRAME ASSEMBLY OF COLOR PICTURE TUBE

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner
for Patents
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. §1.56, and §§1.97 and 1.98 as amended, Applicant cites, provides copies and discusses the following art references:

<u>US Patent No.</u>	<u>Inventor</u>	<u>Date</u>
• 4,942,332	Adler et al.	7/90
• 4,973,283	Adler et al.	11/90
• 4,926,089	Moore	5/90
• 3,638,063	Tachikawa et al.	1/72
<u>Foreign Patent No.</u>	<u>Inventor</u>	<u>Date</u>
• JP2000-77007	Suzuki et al.	3/2000

Adler et al.'332 discloses tied slit mask for color cathode ray tubes.

Adler et al.'283 discloses a method of manufacturing a tied slit mask CRT.

Moore'089 discloses tied slit foil shadow mask with false ties.

Tachikawa et al.'063 discloses grid structure for color picture tubes.

Suzuki et al.'007 discloses color cathode-ray tube that can attenuate vibration of an entire shadow mask positively with a simple structure.

The citation of the foregoing references is not intended to constitute an assertion that other or more relevant art does not exist. Accordingly, the Examiner is requested to make a wide-ranging and thorough search of the relative arts.

No fee is incurred by this Statement.

Respectfully submitted,



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